

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Cangshan XU et al.

Application No. 09/752,509

Filed: December 27, 2000

For: METHODS FOR MAKING REINFORCED

WAFER POLISHING PADS AND APPARATUSES IMPLEMENTING

THE SAME

Group Art Unit: 3723

Examiner: D.Nguyen

Atty. Docket No. LAM2P223A

Date: June 10, 2002

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on June 10, 2002.

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are an ched, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to consider these references and to acknowledge such consideration by initialing the attached PTO Form 1449 at the appropriate locations.

Applicants state that each item of information listed in the attached PTO Form 1449 was cited in a communication in a counterpart international application not more than three months prior to the filing of this statement. For the Examiner's use and information, a copy of the pertinent portion of the International Search Report in the corresponding international application is attached. In the event any fees are due to effect consideration of the references, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0805 (Order No. LAM2P223A).

Respectfully submitted, MARTINE & PENILLA, LLP

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